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Rule 312
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C Moore

PATENT
740756-2154

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)
Shunpei YAMAZAKI et al.) Art Unit: 2813
Application No.: 09/580,485)
Filed: May 30, 2000) Examiner: Asok K. SARKAR
For: METHOD FOR MANUFACTURING AN)
ELECTRO-OPTICAL DEVICE)

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CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the Patent and Trademark Office Fax No. (703) 872-9317 on November 15, 2002.

Adile M. Stampen
Adile Stampen

AMENDMENT UNDER 37 C.F.R. 1.312

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

The following comments and amendments are submitted in response to the Notice of Allowability (PTOL-37) of September 19, 2002 for the above-captioned patent application.

IN THE CLAIMS:

Please amend claim 1 as follows.

1. (Thrice Amended) A method for manufacturing an electrical device, said method comprising:

forming at least a thin film transistor on an insulating surface;

forming a first insulating film comprising an organic resin over the thin film transistor;